

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional) SEC.1189		Application Number 10/657,140		
				Applicant(s) Hong-Mi PARK et al.				
				Filing Date September 9, 2003		Group Art Unit 2825		
U.S. PATENT DOCUMENTS								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
U.S. PATENT APPLICATION PUBLICATIONS								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
VY		1998-82870 A	12-5-1998	KOREA			ABST.	
VY		JP 10064902	6-3-1998	JAPAN			ABST.	
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>								
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N. Y. [Signature]		01/27/05						
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SHEET 1 OF 1